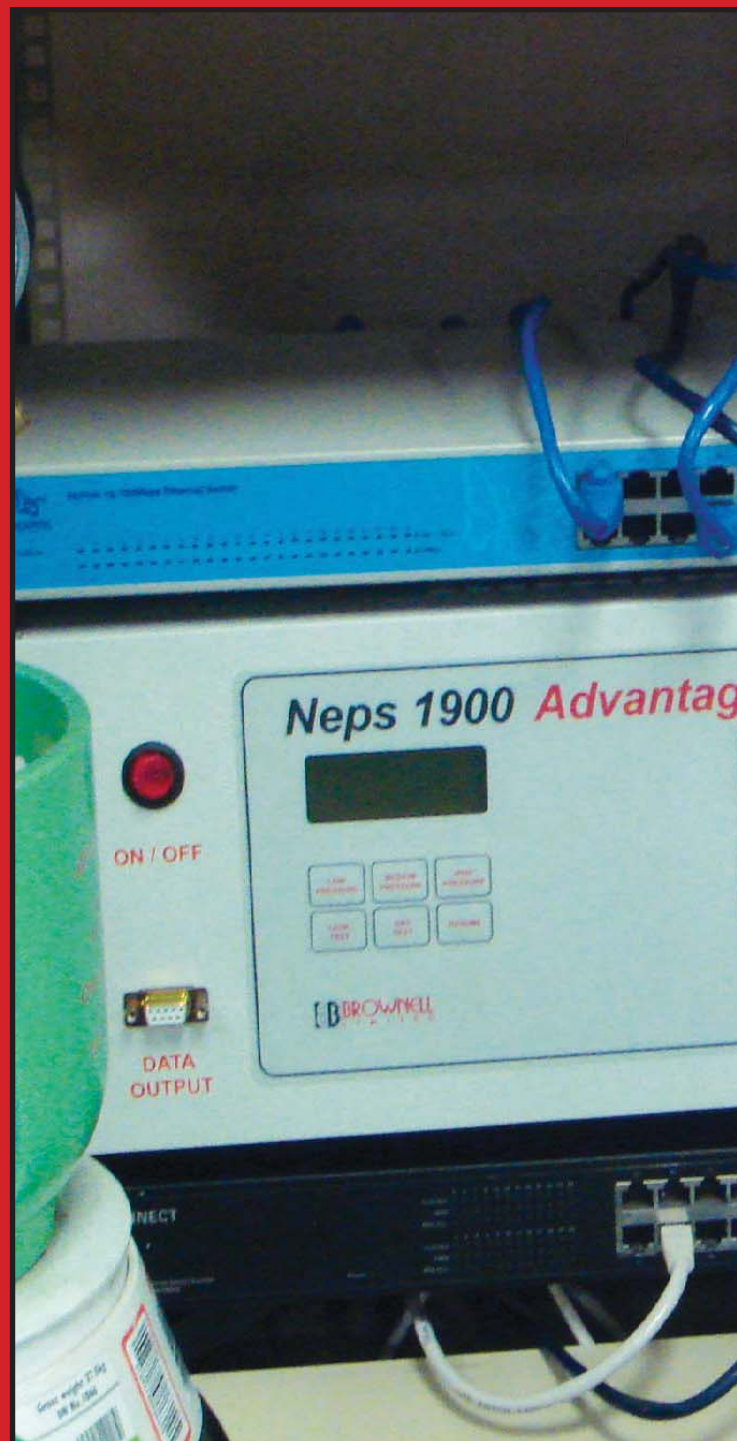


NEPS1900 RACK MOUNTED Nitrogen Purging System

The **NEPS1900 RACK MOUNTED** is the latest development for improving the effective and efficient use of dry nitrogen, which purges electronic, optical, high voltage laser systems and equipment requiring gas drying and inhibiting of oxygen.

High humidity and water vapor can have a deleterious impact on the use, operation, and long-term reliability of instruments and systems.



Specialist Purging Technology

The Complete Purging System

The NEPS1900 RACK MOUNTED is designed to maximize the dry gas purging process for humidity removal, with a host of capabilities and functionality for effective and efficient control during the purging operation.

Easy Operation

NEPS1900 RACK MOUNTED is fully self-contained. Simply connect a dry gas source to the inlet connection and the equipment port. The NEPS1000 ADVANTAGE is ready to operate.

Economic Gas Use

One of the NEPS1900 RACK MOUNTED benefits is its use of the purge gas used for purging. By using a single pipe connection the purge gas is controlled and dispersed throughout the Instrument or System being purged. During the depressurization phase of purging the purge gas is isolated.

User-Friendly

The NEPS1900 RACK MOUNTED has easy to use selectable programming, which can be set to view process control values and display dew point measurements in °C or °F with pressure in Kpa or psi. Highly visible liquid crystal displays provide constant information and readouts during operation and use.

Equipment Leak Testing

The NEPS1900 RACK MOUNTED comes with a selection of three built-in leak testing capabilities to verify the sealing standard of the equipment to be purged. Pressure testing can be conducted in pressures of 10.3 Kpa (1.5 psi), 17.2 Kpa (2.5 psi), and 34.5 Kpa (5.0 psi). Pressure leak/rate display resolution is 0.01 psi.

Gas Quality Testing

The dryness of the gas is important to the effectiveness of the purging operation and the NEPS1900 RACK MOUNTED dew point monitor can be used to check the dryness of the gas prior to commencing the purging operation.

Universal Voltage

The NEPS1900 RACK MOUNTED can be operated globally. Voltages and frequencies range from 100 to 230 VAC at 50-60 Hz.

Single Connection Purging

Traditional conditioning with dry nitrogen, gas or air depends on the flow of gas from an entry connection to an outlet port. In this mode the gas will follow the simplest and easiest path to the outlet connection. This can often lead to "pockets" of unconditioned gas.

Using NEPS1900 RACK MOUNTED the mode of operation changes to a more efficient single connection purging process, which also uses a choice of three selectable pressure cycles to ensure the dry gas influences all the space volume within equipment.

There are two states in the purge cycle. In state one, the unit under test (UUT) is connected to the supply gas until the selected psi is reached. In state two, the unit is connected to the exhaust line until zero psi is reached. The NEPS RACK MOUNTED cycles between these two states until the selected dew point is achieved.

KEY FEATURES & BENEFITS

- Fits Standard 19" Racking
- Easy-to-Use Single Connection Purging
- Dew Point and Pressure Readout
- Remote Dew Point Sensing Option
- Portable and Robust
- User-Programmable
- Automatic Purging Operation
- Dewpointstat Gas Control
- Dew Point Display from +20°C to -80°C
- Maintainable Online
- NATO Approved

AGM CONTAINER CONTROLS, INC. OFFERS A COMPREHENSIVE RANGE OF PURGING INSTRUMENTS FOR MOISTURE REMOVAL IN EQUIPMENT AND SYSTEMS TO PREVENT CONDENSATION AND HUMIDITY DAMAGE

NEPS1900 RACK MOUNTED APPLICATIONS

- Optical Instruments
- LASER Systems
- SF6 Switch Gear
- Printed Circuit Board Conditioning
- Double Glazing Cavities
- Electronic Housings
- Workstations
- Storage Containers
- Surveillance Instruments
- Underwater Equipment
- Thermal Imaging
- Image Intensifiers

What is Dew Point?

The temperature to which air or gas must be cooled for the formation of condensation or frost.

This means dew point is ideal for stating the quality control requirement for purging an instrument or enclosure.

Why Purge?

Modern systems that use printed circuit boards, wires, electronic components, rubbers and plastics in their construction will have potentially significant amounts of moisture.



The amount of built-in moisture often described as “hygroscopic moisture” can be significant in comparison to the moisture (water vapor) contained within the air.

NEPS1900 RACK MOUNTED

- For industries that require a fixed installation the NEPS1900 RACK MOUNTED enables the purging system to be used in standard 19” racks.
- NEPS1900 RACK MOUNTED instruments are supplied with power lead, connecting tubing and full function capability including automatic gas control.
- NEPS1900 RACK MOUNTED can be retro-fitted with the remote sensor adapter.

NEPS1900 RACK MOUNTED Dry Gas Purging System

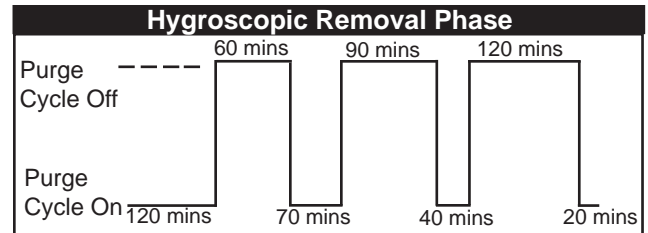
NEPS1900 RACK MOUNTED DEWPOINTSTAT

The Dewpointstat function of the NEPS1900 RACK MOUNTED allows you to monitor and control the removal of built-in hygroscopic moisture within a system or equipment.

The Dewpointstat feature of NEPS1900 RACK MOUNTED enables users to determine the amount of moisture contained within equipment and to implement an optimized gas and purging procedure for production control.

Using the remote dew point sensor option the NEPS1900 RACK MOUNTED monitors the progress of the dew point dryness within the equipment being purged. It then switches off and isolates the dry gas when the selected dew point is achieved.

A data logger can be used to monitor the dew point degradation time, which allows the water vapor transmission rate (WVTR) to be calculated. The rate of water removal (hygroscopic loading) can also be determined during the initial purging phase. (See graph on right.)



TECHNICAL SPECIFICATIONS

Usable Gases	Air, Nitrogen, SF6, Helium, Argon	Power	100-230 volt 50 hz - 60 hz
Selectable Pressure Ranges	10.3 Kpa (1.5 psi) 17.2 Kpa (2.5 psi) 34.4 Kpa (5.0 psi)	Power Consumption	3 amps
Display Range Pressure	0 to 34.4 Kpa (0-5.0 psi)	Dimensions (mm)	490W x 425D x 190H (closed)
Display Range Dew Point	(Selectable) +20°C to -80°C dew point +68°F to -94°F dew point	Weight	6 kg (13 lbs)
Resolution	0.1°C dew point	Ingress Protection	IP54 (closed case)
Accuracy	± 2°C dew point	Operating Temp	-10°C to +50°C (14°F to 122°F)
Data Output Pressure	0 - 5 Volts	Storage Temp	-50°C to + 65°C (-58°F to 149°F)
Data Output Dew Point	0 - 5 Volts	Flow Rate (typical)	20 liters per minute (0.71 CFM)
		Optional Extras	See NEPS Accessories
		Order Code	N1900-AGM